

Seokhwan Bang

List of Publications by Year in descending order

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Version: 2024-02-01

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papers

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citations

1163117

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1372567

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docs citations

10
times ranked

683
citing authors

#	ARTICLE	IF	CITATIONS
1	Drain-Induced Barrier Lowering in Oxide Semiconductor Thin-Film Transistors With Asymmetrical Local Density of States. IEEE Journal of the Electron Devices Society, 2018, 6, 830-834.	2.1	10
2	A study on H ₂ plasma treatment effect on a-IGZO thin film transistor. Journal of Materials Research, 2012, 27, 2318-2325.	2.6	83
3	Photocurrent detection of chemically tuned hierarchical ZnO nanostructures grown on seed layers formed by atomic layer deposition. Nanoscale Research Letters, 2012, 7, 290.	5.7	76
4	Dual optical functionality of local surface plasmon resonance for RuO ₂ nanoparticle@ZnO nanorod hybrids grown by atomic layer deposition. Journal of Materials Chemistry, 2012, 22, 14141.	6.7	21
5	AZO/Au/AZO multilayer as a transparent conductive electrode. Physica Status Solidi (A) Applications and Materials Science, 2012, 209, 698-701.	1.8	35
6	The effects of a HfO ₂ buffer layer on Al ₂ O ₃ -passivated indium-gallium-zinc-oxide thin film transistors. Physica Status Solidi - Rapid Research Letters, 2011, 5, 403-405.	2.4	14
7	Microstructural characterization at the interface of Al ₂ O ₃ /ZnO/Al ₂ O ₃ thin films grown by atomic layer deposition. Physica Status Solidi (B): Basic Research, 2011, 248, 1634-1638.	1.5	8
8	Effects of atomic layer deposition temperatures on structural and electrical properties of ZnO films and its thin film transistors. Metals and Materials International, 2010, 16, 953-958.	3.4	8
9	The effect of oxygen remote plasma treatment on ZnO TFTs fabricated by atomic layer deposition. Physica Status Solidi (A) Applications and Materials Science, 2010, 207, 1845-1849.	1.8	60
10	Role of postannealing temperature on the microstructure of Al ₂ O ₃ /ZnO thin films grown by atomic layer deposition for TFT applications. Physica Status Solidi (A) Applications and Materials Science, 2010, 207, 2185-2189.	1.8	9